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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10049755	02/12/2002	250	492.2	2881	QUASH Smith

**APPLICANTS: Moffatt Stephen;

**CONTINUING DATA VERIFIED:
THIS APPLICATION IS A 371 OF PCT/US00/21377 08/04/2000
WHICH CLAIMS BENEFIT OF 60/147,684 05/06/1999

** FOREIGN APPLICATIONS VERIFIED:
NONE

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>	ATTORNEY DOCKET NO
Foreign priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no		3708/203.24.02	
35 USC 119 conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no		Verified and Acknowledged: Examiners's initials	
TITLE : Method and apparatus for holding semiconductor wafers for lithography and other wafer processes			

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
ISSUE FEE		Total Claims	Print Claims for O.G.
Amount Due	Date Paid	DRAWING	
Assistant Examiner		Sheets Drawn	Figs. Drawn
Primary Examiner		Print Figs	
Application Examiner		PREPARED FOR ISSUE	
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